

## **Search Notes**



<b>Application/Control No.</b>	<b>Applicant(s)/Patent under Reexamination</b>
10/552,029	CHANG ET AL.
<b>Examiner</b>	<b>Art Unit</b>
Qiuwen Mi	1655

**SEARCHED**

## **INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

## **SEARCH NOTES (INCLUDING SEARCH STRATEGY)**